## PATENT

Docket No.: M4065.0319/P319

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Ronald Weimer et al.

Serial No.: 09/296,835

Filed: April 22, 1999

Group Art Unit: 2813

Examiner: Not Yet Assigned

For: FABRICATION OF DRAM AND OTHER SEMICONDUCTOR

DEVICES WITH AN INSULATING

FILM USING A WET RAPID THERMAL OXIDATION

**PROCESS** 

Assistant Commissioner for Patents Washington, D.C. 20231

APR 25 2000
APR 25 APR 26 APR

## **STATUS INQUIRY**

Dear Sir:

It is respectfully requested that the attorney named below be advised of the status of the above-identified application. Please advise us of when we might expect to receive an Office Action from the Patent and Trademark Office.

Dated:

Respectfully submitted,

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